

# Prediction of Semiconductor Material Properties by the Properties of Their Constituent Chemical Elements

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We demonstrate that it is possible to predict the semiconductor material properties, like lattice constant and band gap energy, from their chemical stoichiometries and fundamental element properties of the constituents. We use a correlation technique to show that band gap energy is strongly correlated to electronegativity and pseudopotential radii whereas the lattice constant is strongly correlated to melting temperature and atomic number. Prediction of band gap energy and lattice constant of some III–V and II–VI semiconductors is made on the basis of the developed correlation model. The technique can also be applied to predict bulk properties of ternary or quaternary semiconductors.

## Introduction

In the literature, about 100 unitary, 4000 binary, 8000 ternary, and 1000 quaternary systems are reported, while the maximum number of possible systems is 100 for unitary, 4950 for binary, 161 700 for ternary, and 3 921 225 for quaternary.<sup>1</sup> Only 5% and less than 1% of the possible ternary and quaternary systems are experimentally known. There are millions of other possible candidates that are ignored by the Edisonian approach to materials design. A more scientific and systematic approach based on correlation techniques will be needed for a more effective and efficient design of new materials.

Chen et al. used such a correlation approach, a self-architecting neural network, to model the relation between materials structure and properties for the purpose of predicting new materials.<sup>2</sup> The mechanism of atomic behaviors that control the structure and properties of semiconductors is, however, not revealed by such neural network research. In this study, a correlation technique that has been successfully applied either in the prediction of new additives for galvanizing process<sup>3</sup> or in the material design of new nickel metal hydride electrodes<sup>4</sup> will be used for the binary system of semiconductor alloys based on available literature data. It will provide insightful physics that determines the structure and properties of semiconductors. The technique can also be applied and extended to ternary or quaternary systems.

## Experimental Section

Figures 1 and 2 show band gap energy plotted as a function

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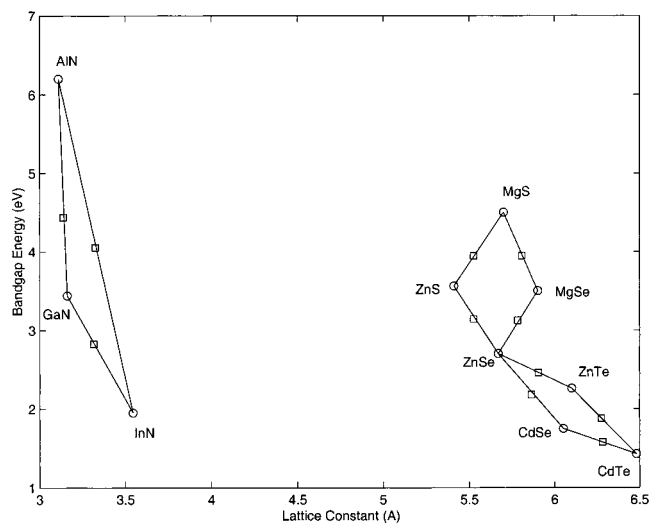
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(1) Rodgers, J. R.; Villars, P. *J. Alloys Compd.* **1993**, *197*, 167.

(2) Chen, P. C. L.; Cao, Y.; LeClair, S. R. *J. Alloys Compd.* **1998**, *279*, 30.

(3) Jin, H. M.; Li, Y.; Wu, P. *J. Mater. Res.* **1999**, *14*, 1791.

(4) Wu, P.; Heng, K. L. *Chem. Mater.* **1999**, *11*, 858.

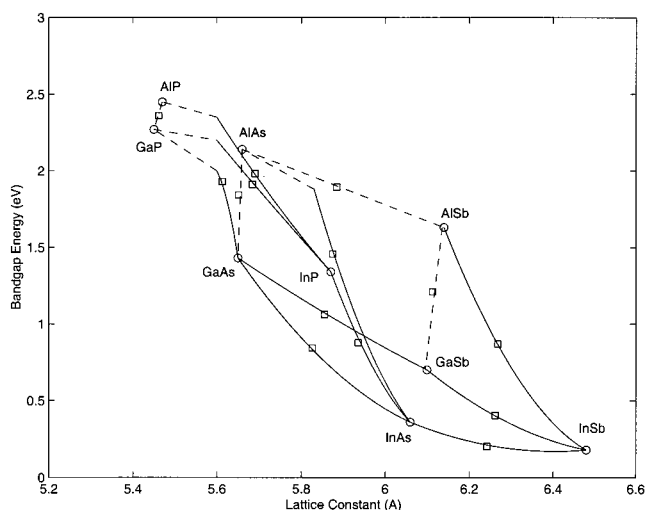


**Figure 1.** Band gap energy and lattice constant of some important semiconductors.

of lattice constant for some common semiconductors.<sup>5</sup> Dashed lines are compounds of indirect band gap materials, and solid lines represent compounds with a direct band gap. Chemical composition of an alloy can be read from these band gap energy–lattice constant plots. For instance, a combination of two binaries such as GaSb and GaAs will give the composition  $\text{GaAs}(i)\text{Sb}(1-i)$  where  $i$  is the mole fraction of As. When  $i = 0$ , the point is at GaSb, and when  $i = 1$ , it is at GaAs. When  $i$  varies from 0 to 1, the point varies continuously along the curve joining the two end points. The exact point on the curve is obtained from the fact that its lattice constant is proportionately contributed in the ratio of the mole fractions of the binary constituents. For simplicity, our binary system only consider the compositions  $i = 0, 0.5, \text{ and } 1$ .

To correlate materials properties to their constituent element properties, classification of element properties will be discussed first. Chemical element properties are generally

(5) Madelung, O. *Numerical Data and Functional Relationships in Science and Technology. New Series. Group 3: Crystal and Solid State Physics*; Springer-Verlag: Berlin, 1982.



**Figure 2.** Band gap energy and lattice constant of some important semiconductors.

classified in six groups: size factor, atomic number factor, electrochemical factor, valence-electron factor, cohesive energy factor, and angular valence-orbital factor. The angular valence-orbital factor is not available in the literature for some of the elements and is, therefore, not included in this study. The data listed in Table 1 are used to correlate chemical element properties such as pseudopotential radii, atomic number, melting point, electronegativity, and valence electron from each of the five factors to two semiconductor material properties, lattice constant and band gap energy. This table has a total of 44 records; each record has 14 predictor variables (mole fractions of Al, Cd, Ga, In, Mg, Zn, As, N, P, S, Sb, Se, Te) and 2 response variables (LC = lattice constant, BE = band gap energy). The first 19 records represent  $i$  equals 0 or 1 of the binary system, and the remaining 25 records represent  $i$  equals 0.5. These 25 records are represented by squares in Figures 1 and 2. We apply a 2 sublattice model<sup>6</sup> for all 44  $A_i$ - $B_j$  semiconductors. The first six variables of Table 1 belong to A lattice (group II or III) whereas the next seven variables belong to B lattice (group V or VI). For each record, the values of the variables of A lattice are summed up to unity and similarly for B lattice. The lattice fraction is defined as

$$Y_{A_i} = \frac{n_{A_i}}{\sum_{i=1}^6 n_{A_i}} \quad i = 1-6 \quad (1)$$

$$Y_{B_j} = \frac{n_{B_j}}{\sum_{j=1}^7 n_{B_j}} \quad j = 1-7 \quad (2)$$

where  $n_{A_i}$  and  $n_{B_j}$  are the number of moles of  $A_i$  and  $B_j$  in lattices A and B, respectively.

To build a property map, its coordinates, which will be functions of element properties and element concentrations in the alloy, have to be defined. For an  $A_i$ - $B_j$  atomic pair, the difference between atom  $A_i$  and atom  $B_j$  in terms of element property  $P$  (i.e.,  $P_{A_i}$  for  $A_i$  and  $P_{B_j}$  for  $B_j$ ) is

$$Q_{A_i B_j} = |P_{A_i} - P_{B_j}| \quad i = 1-6, j = 1-7 \quad (3)$$

Subsequently, in a multicomponent and 2 sublattice alloy, a property map coordinate,  $O_p$  (with respect to element property  $P$ ), was defined as follows:

$$O_p = \sum_{A_i} \sum_{B_j} Y_{A_i} Y_{B_j} Q_{A_i B_j} \quad (4)$$

where  $Y_{A_i} Y_{B_j}$  is proportional to the total number of  $A_i$ - $B_j$  pairs and  $O_p$  is, therefore, the overall element property difference of all nearest-neighbor atomic pairs in the alloy.

Some properties of  $A_i$  and  $B_j$  elements are listed in Table 2.<sup>7</sup> In the present work, a few element properties such as electronegativity ( $E$ , eV<sup>1/2</sup>), atomic number (AN), melting point ( $T$ , K), pseudopotential radii ( $R$ , au), and valence electron number ( $V$ ) are selected to define the property map coordinates based on eqs 1-4. Coordinates  $O_1$ ,  $O_2$ ,  $O_3$ ,  $O_4$ , and  $O_5$  based on element properties  $E$ , AN,  $T$ ,  $R$ , and  $V$ , respectively, are generated as shown in Table 3 together with LC and BE. All records are divided into two classes based on the values of LC and BE. Class label  $C_1$  is assigned to be 1 if  $LC > 5.8$  or  $LC < 3.6$  and 2 if  $3.6 < LC < 5.8$ . Similarly, class label  $C_2$  is assigned value 1 if  $BE > 2.5$  and 2 if  $BE < 2.5$ .

## Results and Discussion

A simple correlation between lattice constant, band gap energy of the binary alloy, and the chemical element properties is established by an in-house artificial intelligence system APEX (Advanced Process Expert).<sup>8</sup> In particular, a set of artificial intelligence techniques<sup>8</sup> is employed by APEX to search among all the possible element properties, the most significant properties that may govern lattice constant, and band gap energy of a binary semiconductor system. In this paper, band gap energy and lattice constant are identified by APEX to be strongly correlated to  $O_1/O_4$  and  $O_3/O_2$ , respectively. To view the pattern on a two-dimensional space, shifting is done to the factors  $O_1/O_4$  and  $O_3/O_2$ , and the record index is used as an artificial axis. In Figure 3, the  $x$ -axis is the shifted ratio  $O_1/O_4$  and the  $y$ -axis represents the record index. It is observed that the two classes are well separated. In Figure 4, the record index is plotted against the shifted ratio  $O_3/O_2$ . It can be seen from Figure 4 that data with  $3.6 < LC < 5.8$  are distributed in a bandlike region between two regions of the data with  $LC > 5.8$  or  $LC < 3.6$ .

To predict LC and BE from the chemical properties, a neural network model is developed for each of the bulk properties. For this purpose, neural network model builder<sup>8</sup> of APEX is used. Noise is removed from the sample pool before the neural network training. In particular, records with lattice constant less than 4.0 are removed from the original data since the model focuses more on the high lattice constant side. In our case study, a random validation set containing 10% of the samples (four records) is held out to implement early stopping<sup>9</sup> to help prevent overfitting and to improve generalization for both the bulk properties. The correlation of predicted values to actual values for training set and validation set of lattice constant are 0.95 and 0.99, respectively. The aforementioned values for band gap energy are 0.97 and 0.98, respectively. The values of lattice constant and band gap energy from experiments versus those predicted by the neural networks are shown in Figures 5-8. It is observed from these figures

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(8) Heng, K. L.; Jin, H. M.; Li, Y.; Wu, P. *J. Mater. Chem.* **1999**, *9*, 837.

(9) Nelson, M. C.; Illingworth, W. T. *A Practical Guide to Neural Nets*; Addison-Wesley: Reading, MA, 1991; p 165.

(6) Pelton, A. D. *Calphad J.* **1988**, *12*, 127.

Table 1. Some Basic Semiconductor Data from Literature<sup>5</sup>

no.	Al	Ga	In	Zn	Cd	Mg	N	P	As	Sb	S	Se	Te	LC (Å)	BE (eV)
1	1	0	0	0	0	0	1	0	0	0	0	0	0	3.11	6.20
2	1	0	0	0	0	0	0	1	0	0	0	0	0	5.47	2.45
3	1	0	0	0	0	0	0	0	1	0	0	0	0	5.66	2.14
4	1	0	0	0	0	0	0	0	0	1	0	0	0	6.14	1.63
5	0	1	0	0	0	0	1	0	0	0	0	0	0	3.16	3.44
6	0	1	0	0	0	0	0	1	0	0	0	0	0	5.45	2.27
7	0	1	0	0	0	0	0	0	1	0	0	0	0	5.65	1.43
8	0	1	0	0	0	0	0	0	0	1	0	0	0	6.10	0.70
9	0	0	1	0	0	0	1	0	0	0	0	0	0	3.54	1.95
10	0	0	1	0	0	0	0	1	0	0	0	0	0	5.87	1.34
11	0	0	1	0	0	0	0	0	1	0	0	0	0	6.06	0.36
12	0	0	1	0	0	0	0	0	0	1	0	0	0	6.48	0.18
13	0	0	0	1	0	0	0	0	0	0	1	0	0	5.41	3.56
14	0	0	0	1	0	0	0	0	0	0	0	1	0	5.67	2.70
15	0	0	0	1	0	0	0	0	0	0	0	0	1	6.10	2.26
16	0	0	0	0	1	0	0	0	0	0	0	1	0	6.05	1.75
17	0	0	0	0	1	0	0	0	0	0	0	0	1	6.48	1.43
18	0	0	0	0	0	1	0	0	0	0	1	0	0	5.70	4.50
19	0	0	0	0	0	1	0	0	0	0	0	1	0	5.90	3.50
20	0.5	0.5	0	0	0	0	1	0	0	0	0	0	0	3.14	4.44
21	0.5	0	0.5	0	0	0	1	0	0	0	0	0	0	3.32	4.05
22	0	0.5	0.5	0	0	0	1	0	0	0	0	0	0	3.31	2.82
23	0	0	0	0.5	0	0.5	0	0	0	0	1	0	0	5.52	3.95
24	0	0	0	0	0	1	0	0	0	0	0.5	0.5	0	5.81	3.95
25	0	0	0	1	0	0	0	0	0	0	0.5	0.5	0	5.52	3.14
26	0	0	0	0.5	0	0.5	0	0	0	0	0	1	0	5.78	3.13
27	0	0	0	0.5	0.5	0	0	0	0	0	0	1	0	5.86	2.18
28	0	0	0	1	0	0	0	0	0	0	0	0.5	0.5	5.90	2.46
29	0	0	0	0	1	0	0	0	0	0	0	0.5	0.5	6.28	1.58
30	0	0	0	0.5	0.5	0	0	0	0	0	0	0	1	6.27	1.88
31	0.5	0.5	0	0	0	0	0	1	0	0	0	0	0	5.46	2.36
32	0	1	0	0	0	0	0	0.5	0.5	0	0	0	0	5.61	1.93
33	0.5	0.5	0	0	0	0	0	0	1	0	0	0	0	5.65	1.84
34	0	0.5	0.5	0	0	0	0	1	0	0	0	0	0	5.68	1.91
35	0.5	0	0.5	0	0	0	0	1	0	0	0	0	0	5.69	1.98
36	1	0	0	0	0	0	0	0	0.5	0.5	0	0	0	5.88	1.89
37	0.5	0	0.5	0	0	0	0	0	1	0	0	0	0	5.87	1.46
38	0	1	0	0	0	0	0	0	0.5	0.5	0	0	0	5.85	1.06
39	0.5	0.5	0	0	0	0	0	0	0	1	0	0	0	6.11	1.21
40	0	0.5	0.5	0	0	0	0	0	1	0	0	0	0	5.82	0.84
41	0	0	1	0	0	0	0	0.5	0.5	0	0	0	0	5.94	0.88
42	0.5	0	0.5	0	0	0	0	0	0	1	0	0	0	6.27	0.87
43	0	0.5	0.5	0	0	0	0	0	0	1	0	0	0	6.26	0.40
44	0	0	1	0	0	0	0	0	0.5	0.5	0	0	0	6.24	0.20

Table 2. Some Basic Chemical Element Properties

element	electro-negativity ( $E$ , eV <sup>1/2</sup> )	atomic no. (AN)	melting temp ( $T$ , K)	pseudo-potential radii ( $R$ , au)	valence electron ( $V$ )
Al	1.61	13	933	1.675	3
Cd	1.69	48	594	2.215	12
Ga	1.81	31	302	1.695	3
In	1.78	49	429	2.05	3
Mg	1.31	12	922	2.03	2
Zn	1.65	30	692	1.88	12
As	2.18	33	1090	1.415	5
N	3.04	7	63	0.54	5
P	2.19	15	317	1.24	5
S	2.58	16	388	1.1	6
Sb	2.05	51	904	1.765	5
Se	2.55	34	494	1.285	6
Te	2.1	52	722	1.67	6

that the predicted values are in good agreement with the experimental values.

We further test the correlation model by screening all possible binary III–V compounds. The following 25 compounds are examined assuming they do exist: BN, BP, BAs, BSb, Bbi, AlN, AlP, AlAs, AlSb, AlBi, GaN, GaP, GaAs, GaSb, GaBi, InN, InP, InAs, InSb, InBi, TiN, TiP, TiAs, TiSb, and TiBi. Of the 25 compounds, only BN, BP, BAs, BSb, BBi, AlBi, GaBi, InBi, TiN, TiP, TiAs, TiSb, and TiBi will be selected for testing since

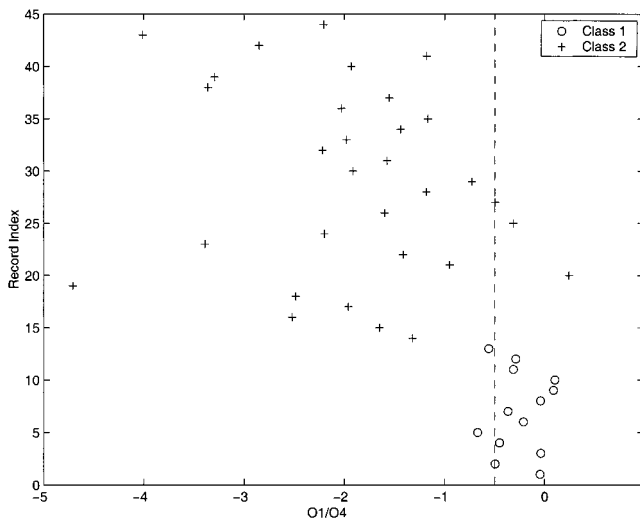
the other 12 compounds have been used before in the development of the correlation model.

For the band gap energy correlation model, InBi and TiBi are found to be out of the range of the training set; i.e., they have either large or small  $O_1/O_4$  values. As a result, these two compounds will not be used in the testing. For the other 11 compounds, BN and TiN are located in the right region of Figure 9 ( $BE > 2.5$ ); BP, BAs, BSb, BBi, AlBi, GaBi, TiP, TiAs, and TiSb are located in the left region of Figure 9 ( $BE < 2.5$ ). Figure 10 shows the prediction of TiSb, InBi, and TiBi using the developed lattice constant correlation model. These three compounds have  $O_3/O_2$  values within the range of the training set. The other 10 compounds are discarded. It is obvious from Figure 10 that InBi is located in the bandlike region ( $3.6 < LC < 5.8$ ). For TiSb and TiBi, they have either  $LC < 3.6$  or  $LC > 5.8$ .

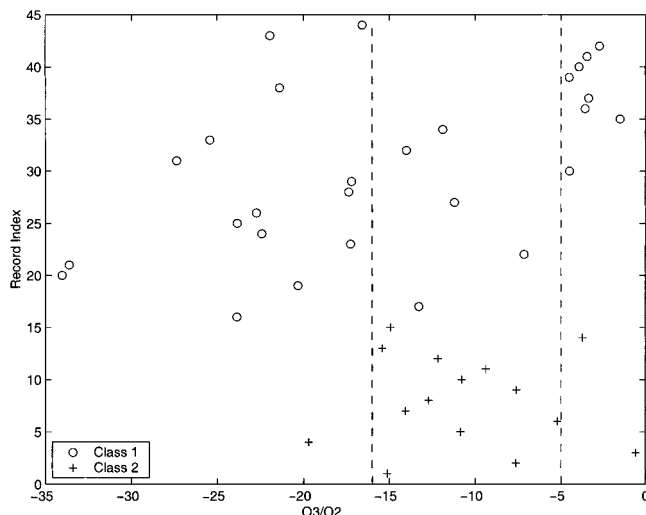
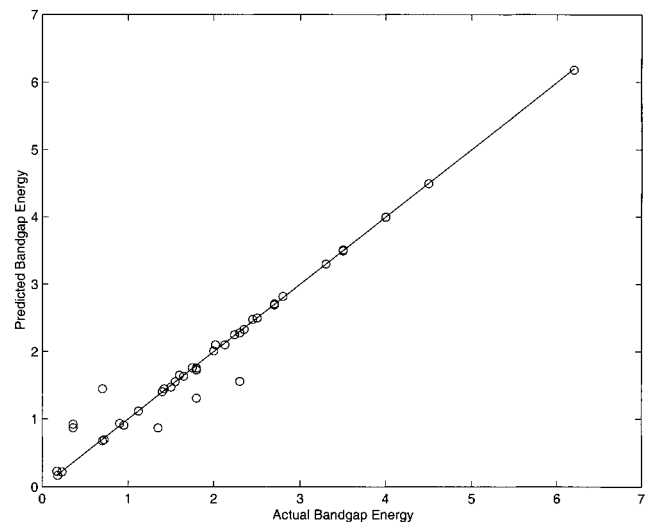
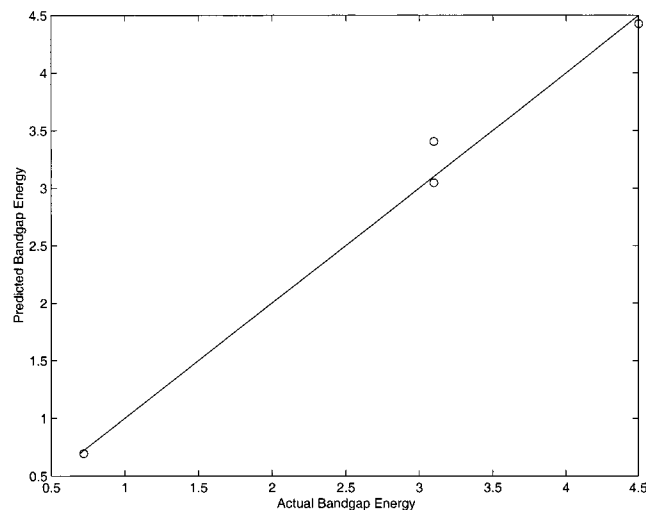
Similarly, group II and VI elements from the periodic table can also be screened and tested using the developed correlation models. Since MgS and MgSe have been used in the models, they are excluded from the test set. The following 28 compounds from the periodic table are tested assuming they do exist: BeO, BeS, BeSe, BeTe, BePo, MgO, MgTe, MgPo, CaO, CaS, CaSe, CaTe, CaPo, SrO, SrS, SrSe, SrTe, SrPo, BaO, BaS, BaSe,

**Table 3. Property Map Coordinates, Response Variables, and Class Labels**

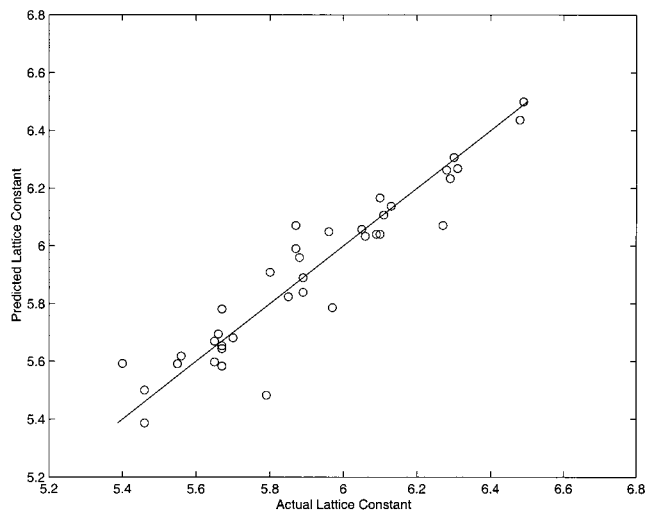
$O_1$	$O_2$	$O_3$	$O_4$	$O_5$	LC (Å)	BE (eV)	$C_1$	$C_2$
1.43	6	859	1.135	2	3.11	6.20	1	1
0.58	2	605	0.435	2	5.47	2.45	2	2
0.57	20	168	0.260	2	5.66	2.14	2	2
0.44	38	18	0.090	2	6.14	1.63	1	2
1.23	24	239	1.155	2	3.16	3.44	1	1
0.38	16	15	0.455	2	5.45	2.27	2	2
0.37	2	788	0.280	2	5.65	1.43	2	2
0.24	20	602	0.070	2	6.10	0.70	1	2
1.26	42	366	1.510	2	3.54	1.95	1	2
0.41	34	112	0.810	2	5.87	1.34	1	2
0.40	16	661	0.635	2	6.06	0.36	1	2
0.27	2	475	0.285	2	6.48	0.18	1	2
0.93	14	304	0.780	6	5.41	3.56	2	1
0.90	4	198	0.595	6	5.67	2.70	2	1
0.45	22	30	0.210	6	6.10	2.26	1	2
0.86	14	100	0.930	6	6.05	1.75	1	2
0.41	4	128	0.545	6	6.48	1.43	1	2
1.27	4	534	0.930	4	5.70	4.50	2	1
1.24	22	428	0.745	4	5.90	3.50	1	1
1.33	15	549	1.145	2	3.14	4.44	1	1
1.345	24	612.5	1.323	2	3.32	4.05	1	1
1.245	33	302.5	1.333	2	3.31	2.82	1	1
1.10	9	419	0.855	5	5.52	3.95	2	1
1.255	13	481	0.838	4	5.81	3.95	1	1
0.915	9	251	0.688	6	5.52	3.14	2	1
1.07	13	313	0.670	5	5.78	3.13	2	1
0.88	9	149	0.763	6	5.86	2.18	1	2
0.675	13	114	0.403	6	5.90	2.46	1	2
0.635	9	114	0.738	6	6.28	1.58	1	2
0.430	13	79	0.378	6	6.27	1.88	1	2
0.48	9	310	0.445	2	5.46	2.36	2	2
0.375	9	401.5	0.368	2	5.61	1.93	2	2
0.47	11	478	0.270	2	5.65	1.84	2	2
0.395	25	63.5	0.633	2	5.68	1.91	2	2
0.495	18	358.5	0.623	2	5.69	1.98	2	2
0.505	29	93	0.175	2	5.88	1.89	1	2
0.485	18	414.5	0.448	2	5.87	1.46	1	2
0.305	11	695	0.175	2	5.85	1.06	1	2
0.34	29	310	0.080	2	6.11	1.21	1	2
0.385	9	724.5	0.458	2	5.82	0.84	1	2
0.405	25	386.5	0.723	2	5.94	0.88	1	2
0.355	20	246.5	0.188	2	6.27	0.87	1	2
0.255	11	538.5	0.178	2	6.26	0.40	1	2
0.335	9	568	0.46	2	6.24	0.20	1	2

**Figure 3.** Classification of band gap energy using electronegativity ( $O_1$ ) and pseudopotential radii ( $O_4$ ).

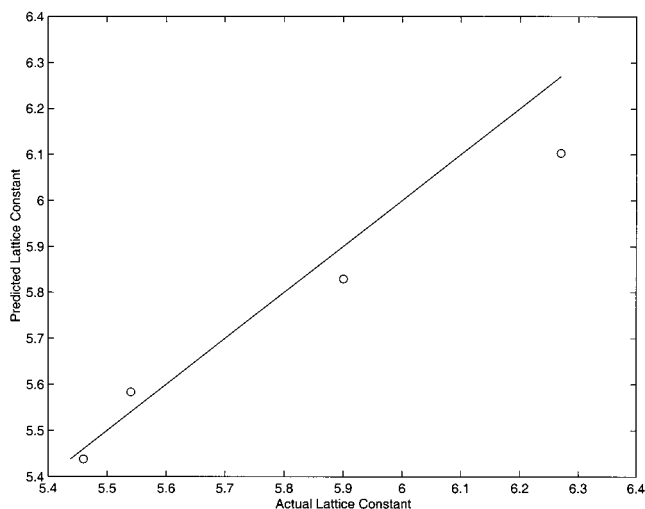
BaTe, BaPo, RaO, RaS, RaSe, RaTe, and RaPo. Out of these 28 compounds, only the following 12 compounds are within the range of the developed correlation models: BeS, MgO, CaO, CaS, CaSe, SrS, SrSe, SrTe,

**Figure 4.** Classification of lattice constant using atomic number ( $O_2$ ) and melting temperature ( $O_3$ ).**Figure 5.** Comparison of actual and predicted band gap energy (training set).**Figure 6.** Comparison of actual and predicted band gap energy (validation set).

BaSe, BaTe, BaPo, and RaPo. All these 12 compounds are located in the right region of Figure 9 ( $BE > 2.5$ ). It is obvious from Figure 10 that the four compounds SrSe,



**Figure 7.** Comparison of actual and predicted lattice constant (training set).



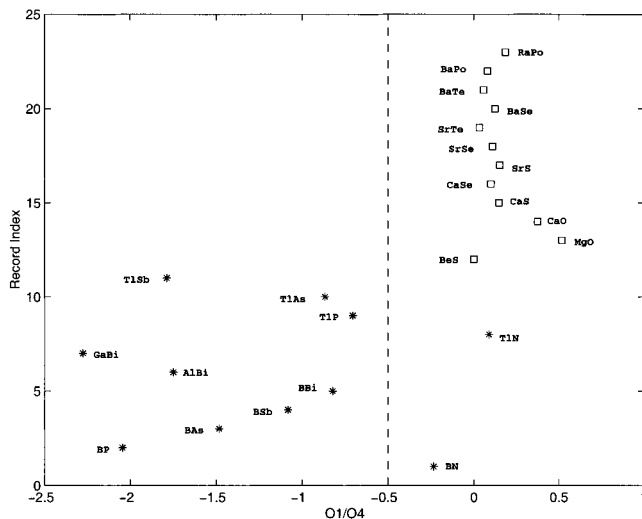
**Figure 8.** Comparison of actual and predicted lattice constant (validation set).

SrTe, BaTe, and RaPo are located in the bandlike region ( $3.6 < LC < 5.8$ ). For the other eight compounds, they have either  $LC < 3.6$  or  $LC > 5.8$ .

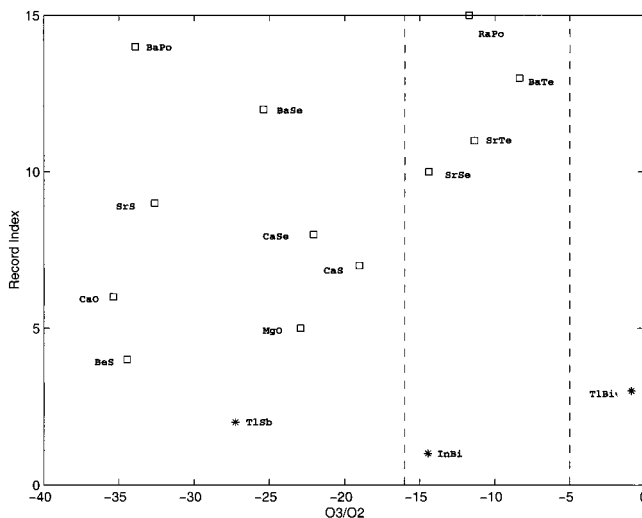
Band gap energy is the energy needed to remove an electron across a bond in the solid. In this paper, the factor  $O_1/O_4$  is identified to be closely related to the band gap energy.  $O_1$  represents electronegativity, which is a measure of the competing attraction of different atoms for the available valence electrons in compound or chemical bond formation. It is related to the difference of valence energy levels of its constituent elements.  $O_4$  represents pseudopotential radii, which is the atomic size difference. Daams<sup>10</sup> showed that the average atomic radius of a compound,  $(R_A + R_B)/2$ , was strongly correlated to the shortest interatomic distance  $d$  (or bond length) for a few material systems:

$$d = k_1(R_A + R_B)/2 + k_2 \quad (5)$$

In eq 5,  $R_A$  and  $R_B$  are the atomic radius of A and B atoms in the  $A_I-B_J$  compound, respectively;  $k_1$  and  $k_2$



**Figure 9.** Prediction of band gap energy of some III-V and II-VI semiconductor compounds (assuming they exist) using electronegativity ( $O_1$ ) and pseudopotential radii ( $O_4$ ).



**Figure 10.** Prediction of lattice constant of some III-V and II-VI semiconductor compounds (assuming they exist) using atomic number ( $O_2$ ) and melting temperature ( $O_3$ ).

are constants that are independent of atomic sizes. From eqs 4 and 5, it is obvious that  $O_4$  is proportional to the shortest interatomic distance  $d$ , which is a measure of the bond strength. In summary,  $O_1$  is a measure of the intrinsic capability of the constituent elements in attracting valence electrons to form a chemical bond, and  $O_4$  (through  $d$ ) is a measure of the short-range atomic arrangement in the compound, which may represent repulsive force between the A-B atomic pair.<sup>11</sup> The term  $O_1/O_4$  can therefore be regarded as a quantity to measure the competition between the attractive and repulsive forces when the compound is formed. In other words, the band gap energy of a binary semiconductor system may be governed by the measure of competition between the attractive and repulsive forces ( $O_1/O_4$ ).

The melting temperature and atomic number are identified to be significant in response to the lattice

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constant in the form of  $O_3/O_2$ . A close relationship between the process of diffusion and melting of metals has been shown by Rice and Nachtrieb.<sup>12</sup> A relation between the activation energy for self-diffusion ( $D$ ) and the melting point ( $T_f$ ) was shown<sup>13</sup>

$$D = KT_f$$

where  $K$  is a constant, and its value is expected to be vary from one system to another. Furthermore, Tiwari<sup>14</sup> showed that this correlation between the parameters of self-diffusion and melting is valid for normal metals as well as the metals showing anomalies in their diffusion behaviors. Therefore,  $O_3$  is proportional to the diffusion behaviors of the element. Atomic number is proportional to the mass of the element. Since the element melting point and atomic number are strongly related to its self-diffusion parameter and mass ( $m$ ), respectively, the term  $O_3/O_2$  is proportional to  $D/m$ . The term  $D/m$  may be regarded as a measure of atomic diffusion capability normalized by its mass or, alternatively, a measure of atomic speed since  $D/m$  has the

same unit as the square of speed. The strong correlation observed between LC and  $D/m$  may suggest that the lattice constant of a binary semiconductor relies on how fast atoms redistribute themselves through diffusion during its formation process.

### Conclusions

Two bulk semiconductor properties, band gap energy and lattice constant, are found strongly correlated to a few fundamental constituent element properties, which are electronegativity and pseudopotential radii for the former and melting temperature and atomic number for the latter. It further suggests that the band gap energy and lattice constant rely on the result of the competition between attractive and repulsive forces and on how easily the atoms may diffuse taking into account their mass, respectively, in the compound formation process. New semiconductors may be designed on the basis of the developed correlation.

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